

Appl. No. 10/810,309
 Amdt. Dated November 29, 2006
 Reply to Final Office Action of September 19, 2006

Attorney Docket No. 81716.0122
 Customer No. 26021

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Isamu AKASAKI et al.

Serial No.: 10/810,309

Confirmation No.: 8006

Filed: March 26, 2004

For: SEMICONDUCTOR APPARATUS,
 METHOD FOR GROWING NITRIDE
 SEMICONDUCTOR AND METHOD
 FOR PRODUCING
 SEMICONDUCTOR APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.116

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Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated September 19, 2006, please amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

Art Unit: 2814
 Examiner: Thao X. Le

I hereby certify that this correspondence is being transmitted via facsimile to:
 (571) 273-6300;

Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450, on

November 29, 2006

Date of Deposit

Diane Zynn

Name

Diane Zynn

11/29/06
 Date